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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Masahiko Kawase

Attorney Docket No.: MURTP095X1

Application No.: 10/629,092

Examiner: Unknown

Filed: July 28, 2003

Group: 3729

Title: METHOD OF PRODUCING CHIP  
THERMISTOR

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on May 25, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Deborah Neill

**REQUEST FOR STATUS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on July 28, 2003 and no response has been received as of this date.

Respectfully submitted,

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